### REMARKS

# Amendments of Claims 13, 15 and 17

Claims 13, 15 and 17 have been amended hereby to better delineate the invention described by the present application.

Specifically, claim 13 has been amended to recite a double-gated/couble-channel FIN MOSFET having vertical fin-shaped silicon-containing channel regions. Support for the double-gated/double-channel FIN MOSFET can be found on page 1, line 13, page 2, lines 27-28, page 3, lines 21, 24-25, and page 4, line 24 of the instant specification as originally filed. Support for vertical fin-shaped silicon-containing channel regions can be found on page 1, line 10, page 2, lines 4-5, and page 9, line 30 of the instant specification as originally filed.

Claim 15 has been amended to depend from claim 14 instead of claim 13, since claim 14 contains the enceedent insis for "said insulating layer" and "said SOI material" recited by claim. 15.

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Claim 17 has been emended to clarify that the gate dielectric is a part of the insulating filmrecited in claim 16.

# Response to the \$102 Rejection of Claims 13-20

In the July 25, 2005 Office Action, the Examinar finalized the previous rejection of claims 13-20 under 35 USC §102(b) as being allegedly anticipated by U.S. Patent No. 5,963,300 to Augusto (bereinefter "Augusto").

Applicants respectfully traverse (he Examiner's rejections, for the following reasons:

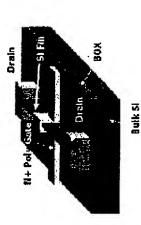
Chira 13, from which claims 14-20 depend, has been hereby amended to positively recite a double-gated/double-channel FIN MOSFEI frat contains vertical fin-shaped silicon-containing

chance regions and a gate region that is self-aligned to use vertical fin-shaped silicon-containing channel regions.

It is well known in the act that the term "FIN" it: the context of an FET structure refers to a thin fur-shaped body, which stands vertically on the substante surface (i.e., the plane defined by this thin fur-shaped body is substantially perpendicular to the substante surface) and functions as the channel region of the FET structure.

For example, the Semiconductor Glossary defines "FinFET" as an MOSFET that has a "fin"-like shaped body with the gate wrapped therearound (see <a href="http://semiconductorglossary.com/">http://semiconductorglossary.com/</a>/

\*\*Reserviceme=FinFET\* as downloaded on September 13, 2005). Rahman, Design and Fabrication of Thi-Gated FinFET\*, 22\*\*Annua. Microelectronic Engineering Conference (May 2004) shows an exemplary FinFET structure, which is reproduced at below for ease of reference:



In contrast, the MISFET device disclosed by the Augusto reference does not contain any vertical in-shaped slibcon-containing channel region, as positively recited by claims 13-20 of the present application. Augusto instead ciscloses a vertical MISFET device that has vertically arranged source, channel, and drain regions, for defining a current flow direction that is vertical to the substrate wafer (see Figure 5 of Augusto). However, nothing in Augusto teaches that the channel region of such a vertical MISFET device is a fin-shaped body that stands vertically on the

substrate wafer. Therefure, the vertical MISFET device disclosed by Augusto does not constitute

FIN MOSFET within the meaning of claims 13-20 of the present application.

Further, nothing in the Augusto reference teaches either the use of a vertical fin-shaped siliconcortaining channe, or the construction of a FIN MOSFET device.

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Applicants? c.a.med invention, as defined by the amended claims 13-20, thus patentably distinguishes over the Augusto reference, by positively recing a double-gated/double-charnel FIN MOSFET that contains vertical fin-shaped silicon-containing channel regions.

# CONCLUSION

If any issues remain cutstanding, incident to the found allowance of the application, the Examiner is recuested to contact the undersigned attorney at (516) 742-4343 to discuss same, in order that this application Based on the foregoing, claims 13-20 as amended herein are in condition for allowance. Issue of a Notice of Allowance for the application is therefore recuested. rray be allowed and passed to issue at an early date.

Respectfully submitted,

Registration No. 39,394 Lesiks.

> SCULLY, SCOTT, MURPHY & PRESSER 400 Garden City Plaza, Suite 300 Garden City, New York 11530 (516) 742-4343 (teleptione) (516) 742-4365 (facsimi.e) LSS/MY:ar

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# Design and Fabrication of Tri-Gated FinFET

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Figure 2 30 Total Cross Section of the PhateET [4]

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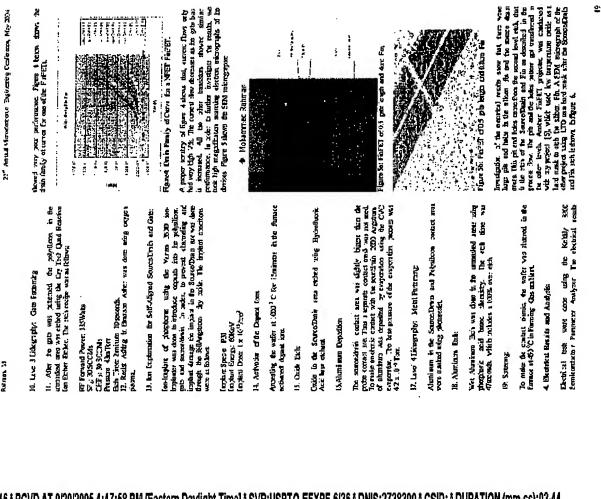
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